



Docket No. 740756-2317

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
Hajime KIMURA) Group Art Unit: 2615
Application No. 09/864,280) Examiner: Lin Ye
Filed: May 25, 2001) Confirmation No. 1263
For: MOS SENSOR AND DRIVE METHOD THEREOF) Date: August 15, 2005

AMENDMENT AFTER FINAL REJECTION

Mail Stop **AF**
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed May 13, 2005, please consider the amendments and remarks in connection with the above-identified application as follows.

Please

Enter!

WJ

8/30/05